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# **Modeling Approaches for CIGS and CdTe Solar Cells: Focus on Uniformity**

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Colorado State University

With help from a large number of students,  
especially Galym Koishiyev

Financial Support from NREL, NSF, and DOE

# **Advantages and Problems for CIGS and CdTe**

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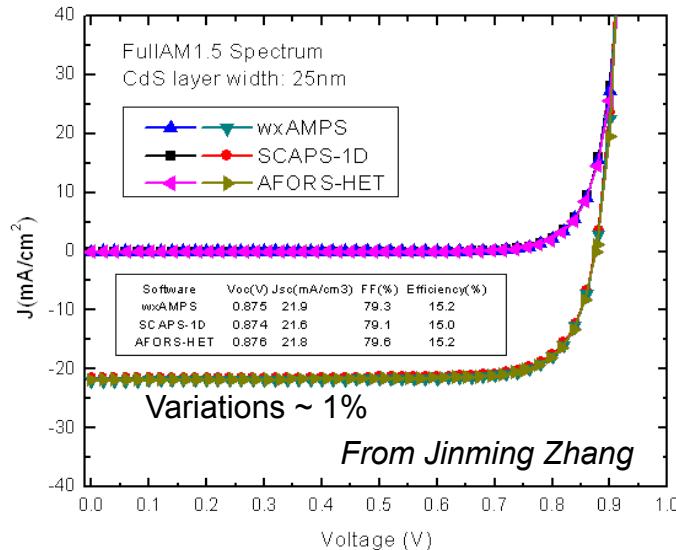
## **ADVANTAGES:**

- (1) Fabrication of large areas is relatively inexpensive (technology similar to optical coatings on glass).
- (2) Materials utilization much smaller when dealing with micron thicknesses.
- (3) Energy pay-back time is low (less than one year).
- (4) Entire structures can be deposited on flexible, low-weight substrates.
- (5) High tolerance to additional defects and impurities.

## **PROBLEMS:**

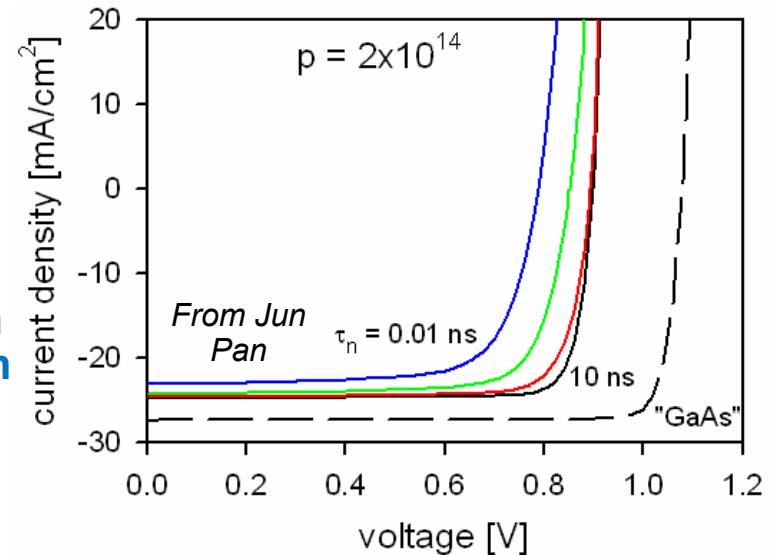
- (a) Thin-film cells are generally composed of heterojunctions which may have band offsets and interfacial states.
- (b) Thin-film thickness and composition may not be uniform.
- (c) Grain boundaries are potential recombination sites and diffusion paths.
- (d) Thin-films tend to have compensating donor and acceptor levels and hence lower carrier densities.

# Approach (1): Numerical Simulation

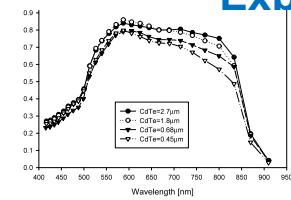


Three software packages

Variation with recombination lifetime



QE as a function of absorber thickness

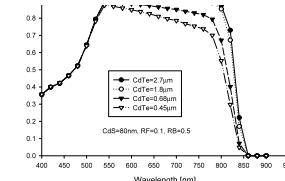


Experimental Data

From Univ.  
Toledo

Numerical Simulation

From  
Jun Pan



# Approach (2): The Diode Equation

CurVA

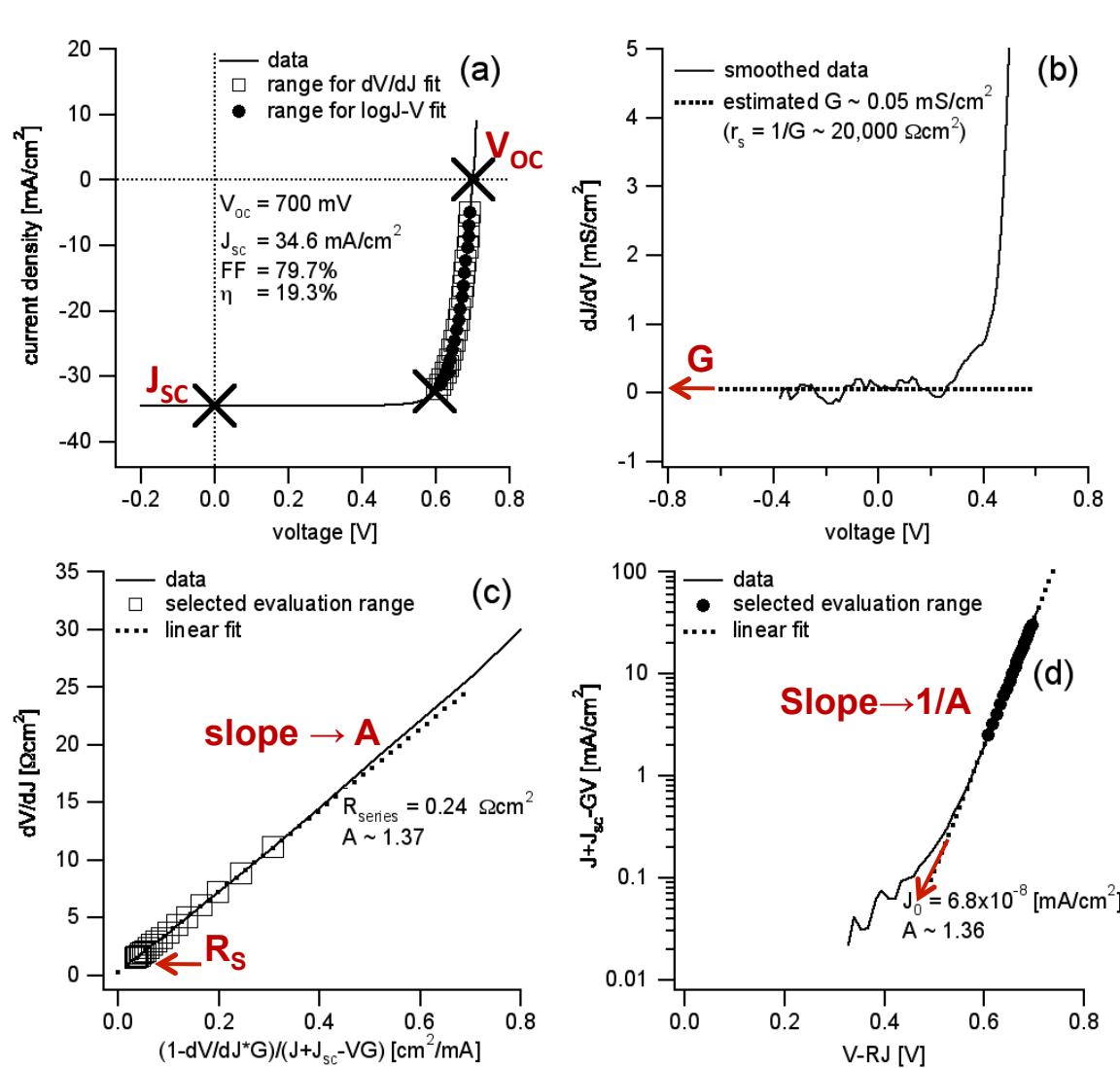
by Markus Gloeckler  
 [based on Hegedus and Shafarman, Prog. in PV 12, 155, (2004)]

Applied here to high-efficiency CIGS cell

Assumes  $J = J_0 \exp[q(V - JR)/AkT] + GV - J_L$

- (1) Plot data four ways
- (2) Select data to fit
- (3) Adjust fit with sliders
- (4) Fitting parameters appear on screen

Note: (c) linearizes the diode equation above:  
 $dV/dJ = R + AkT/(J+J_L)$   
 when  $G = 0$

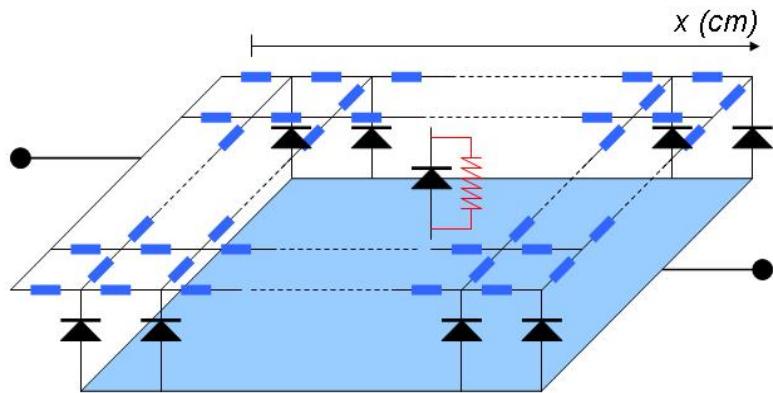


# Approach (3): Circuit Modeling

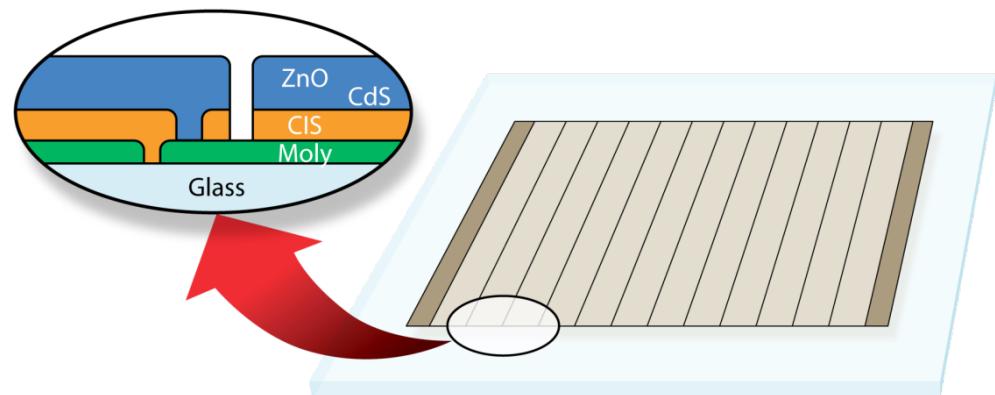
## (3a) Distributed Series Resistance

Circuit Equivalent  
(light source not shown)

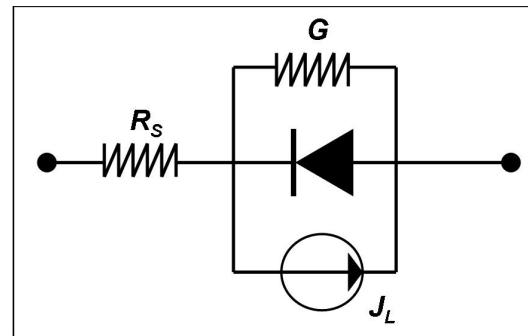
Note: voltage across  
cell may not be uniform.



Pspice™ works well for analysis  
Single alteration to circuit element:  
(will return to the shunt)

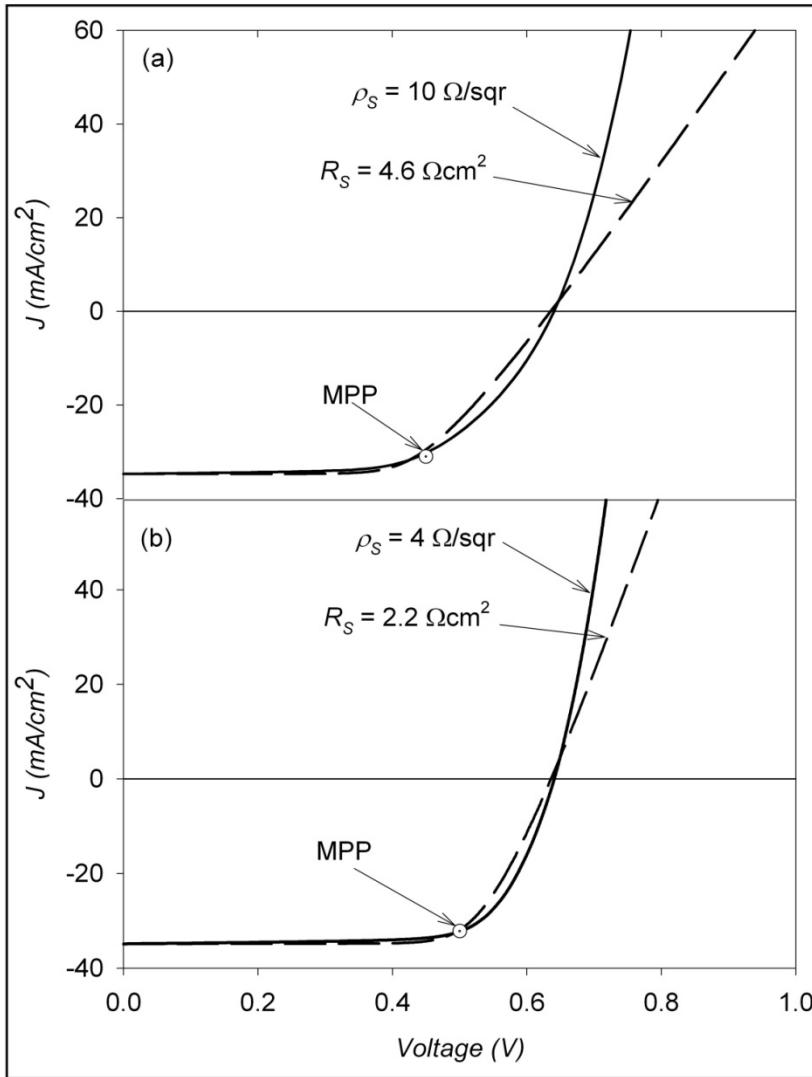


Monolithic integration without grids  
implies large series resistance



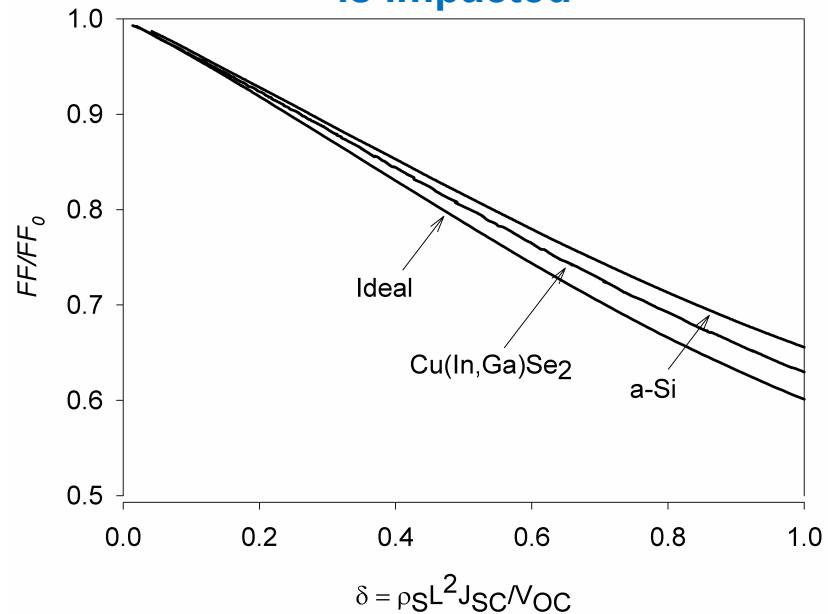
Lumped series resistance  
approximation likely to fail

# Distributed Series Resistance



Big difference between distributed and lumped series resistance

Approximate universal relationship of how fill-factor is impacted



Koishiyev and Sites, SOLMAT 93, 350 (2009)

# Advantages and Problems for CIGS and CdTe

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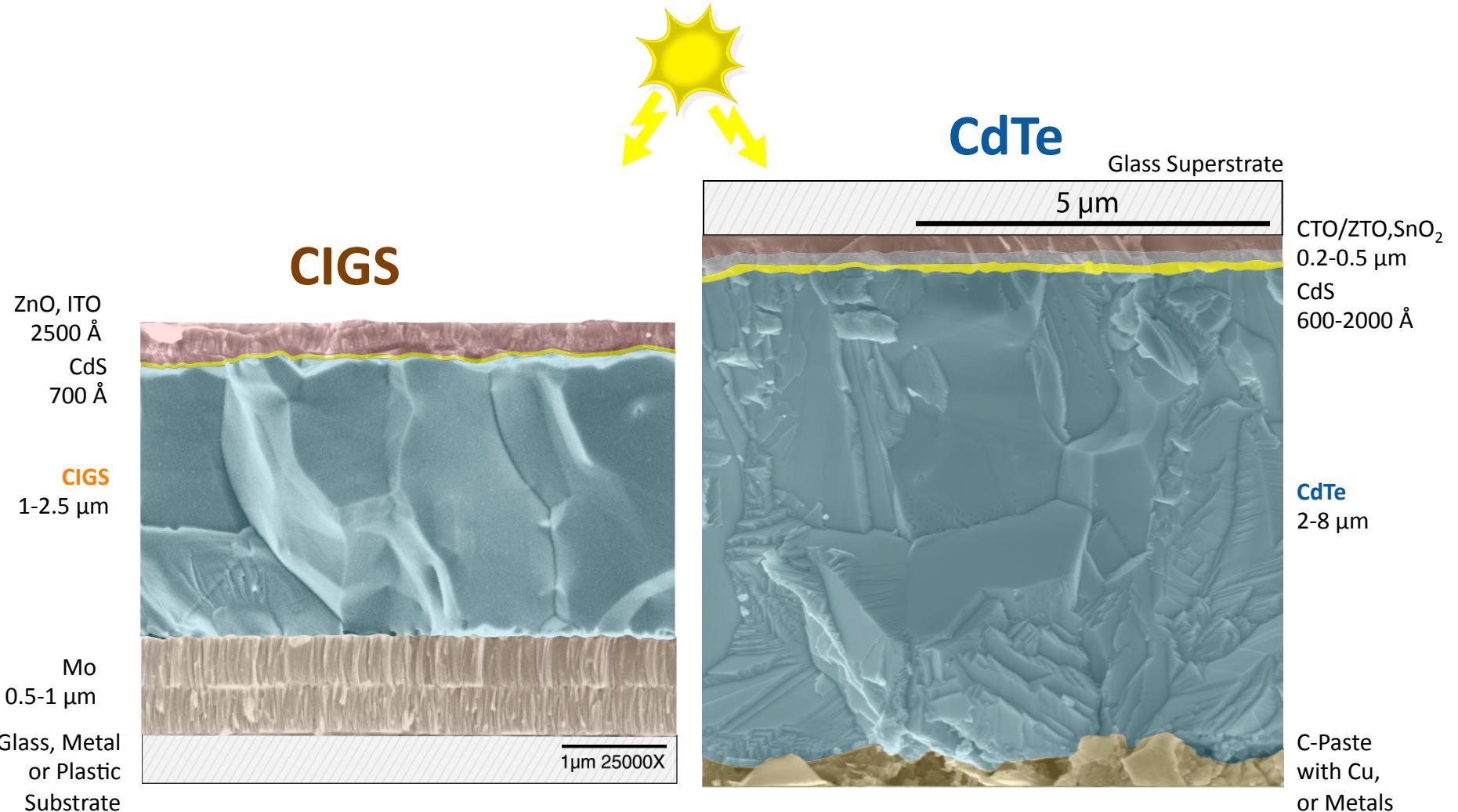
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## PROBLEMS:

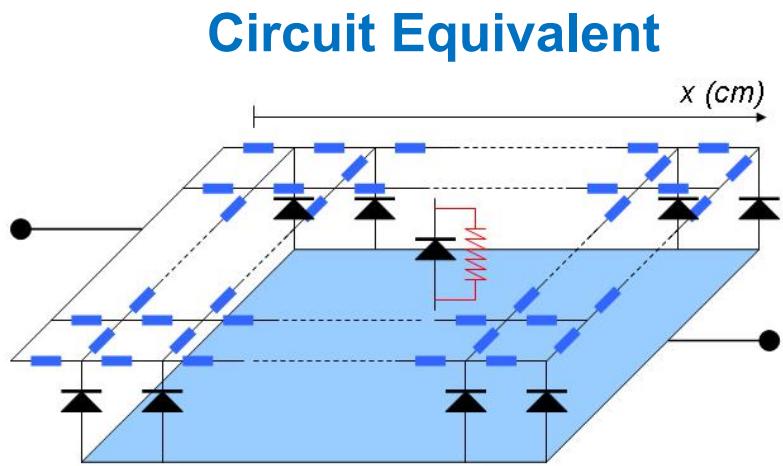
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# CIGS and CdTe Device Structure (Light Above)



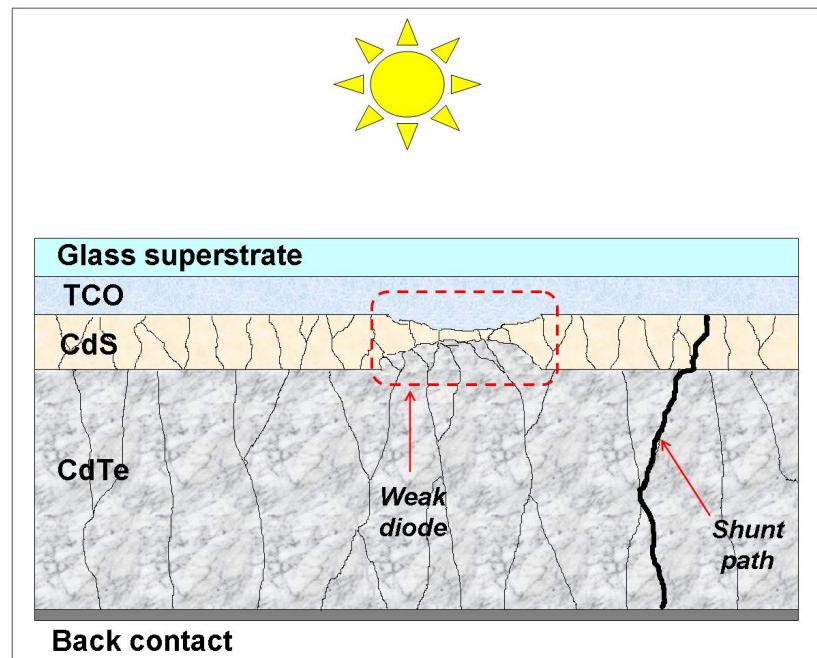
Similar crystallite sizes and shapes; color artificial

## (3b) Circuit Modeling of Non-Uniforities



Single alteration to circuit element:  
Shunt shown, could be a weak diode

**Physical Picture**

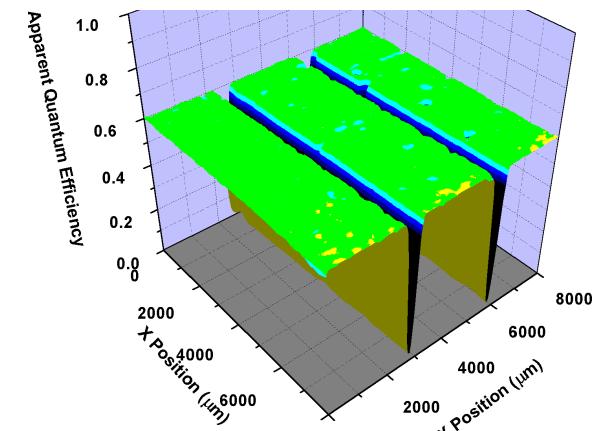
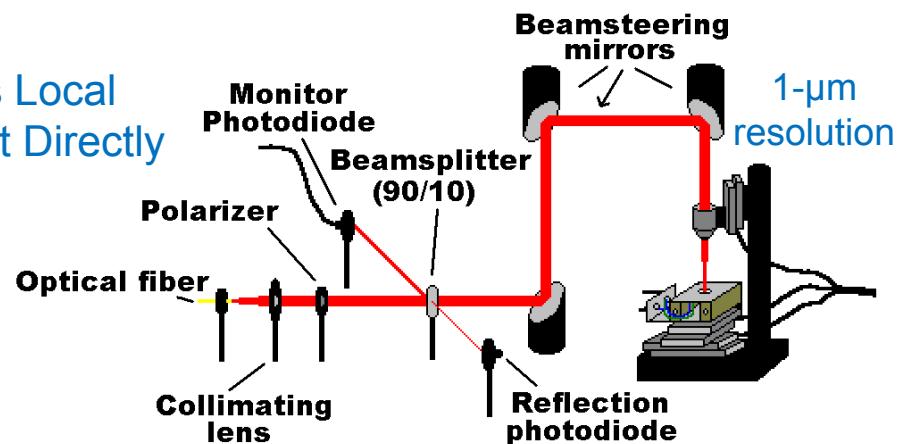


From G. Koishiyev

# Experimental Uniformity Tools

## Light-beam-induced current (LBIC)

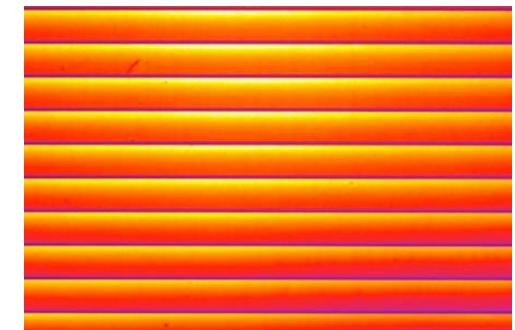
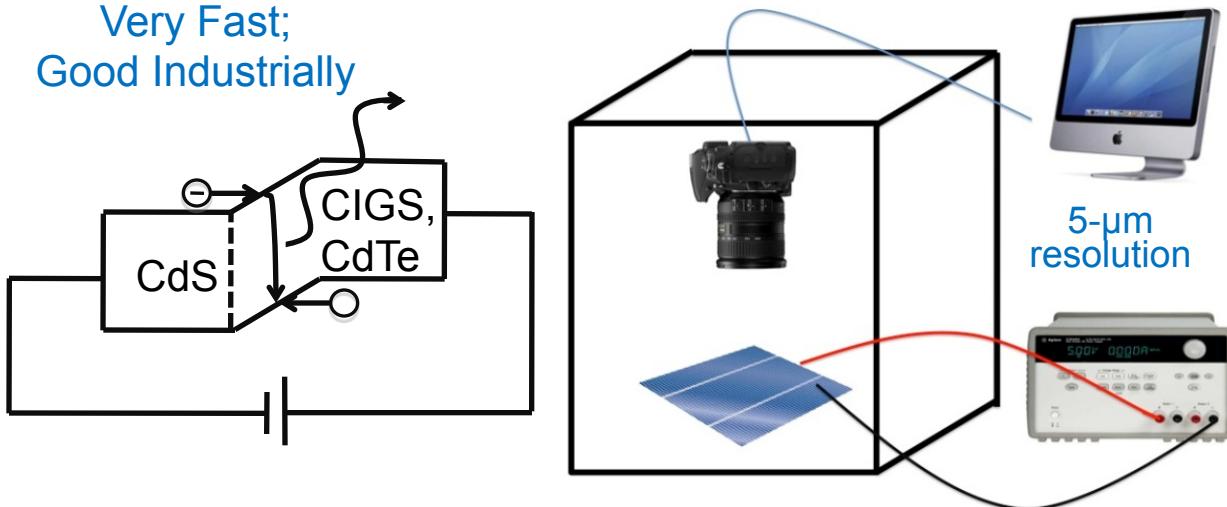
Measures Local Photocurrent Directly



LBIC from CIGS cell

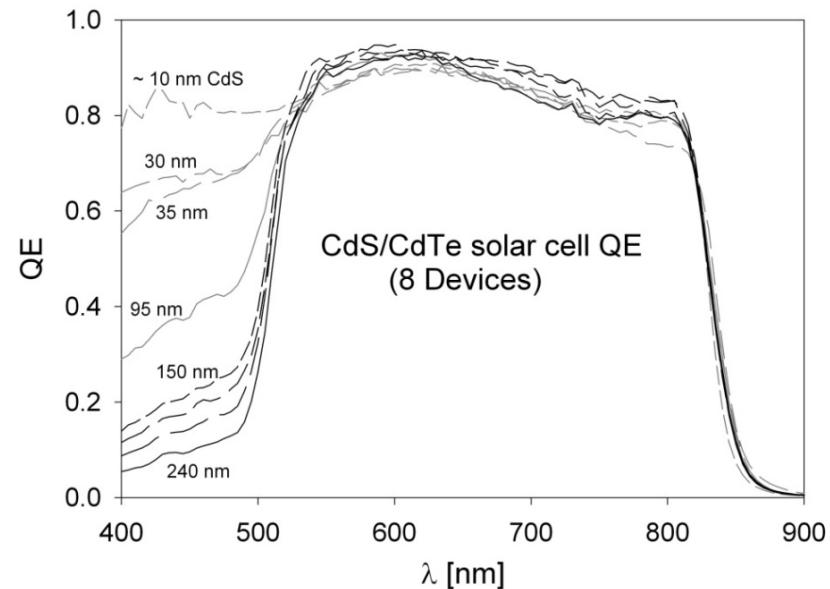
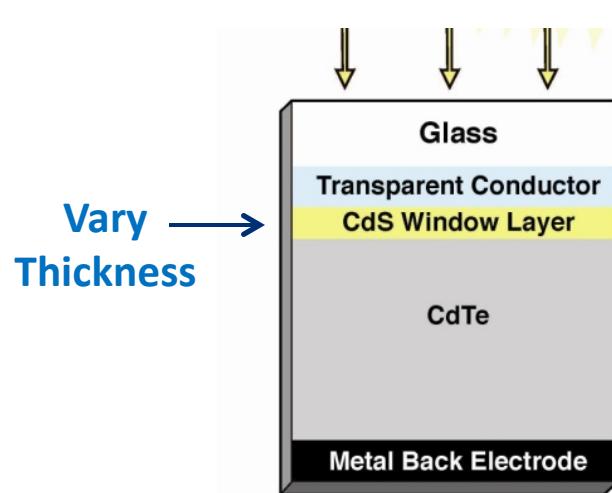
## Electroluminescence (EL)

Very Fast;  
Good Industrially

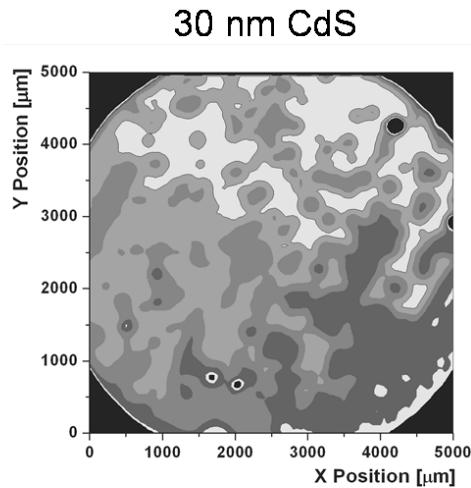


EL from CdTe module

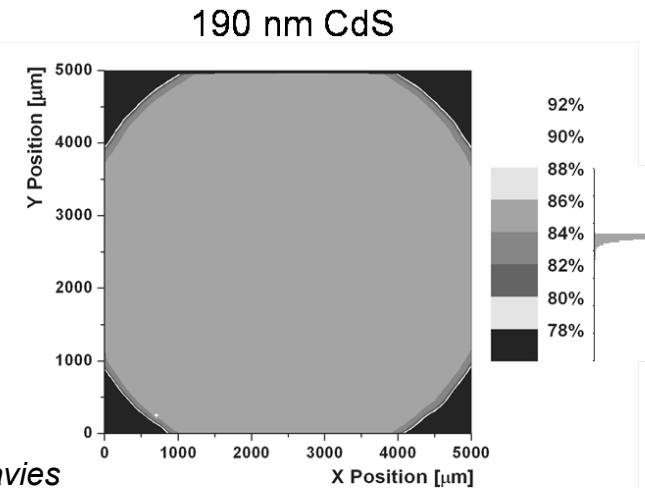
# Window Layer Uniformity



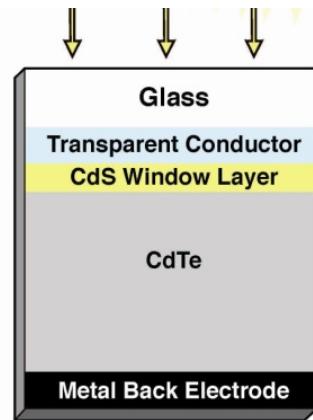
## Low-Resolution LBIC



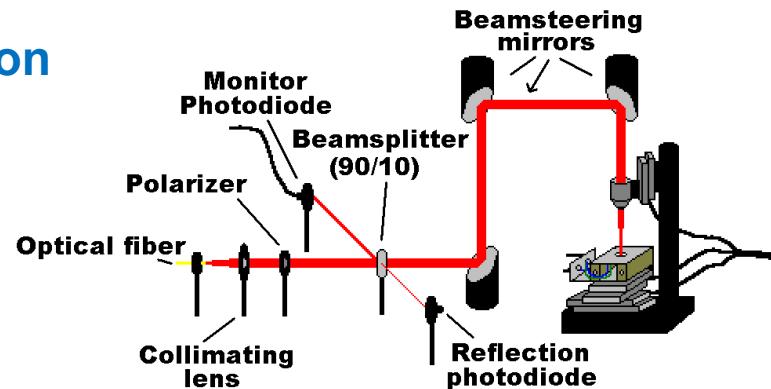
From Alan Davies



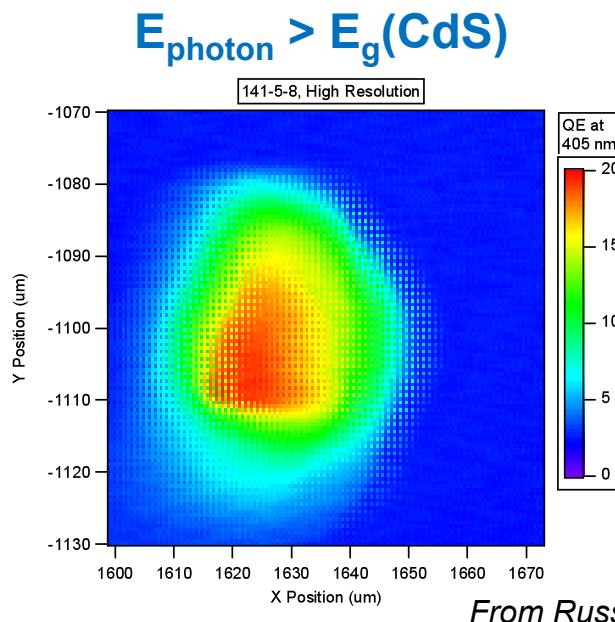
# Small LBIC Defect



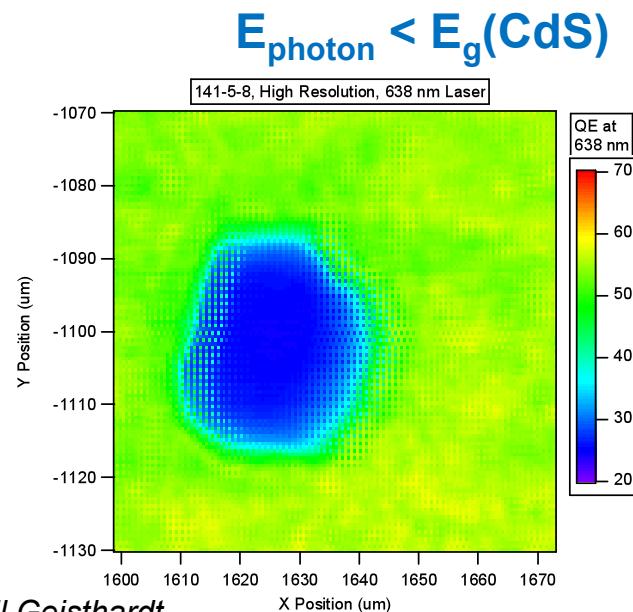
## High-Resolution LBIC



Feature size  
~ 20  $\mu\text{m}$

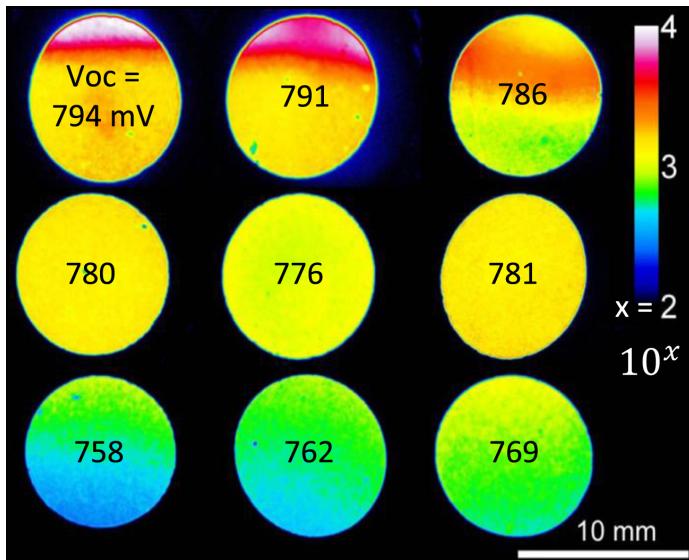


From Russell Geisthardt

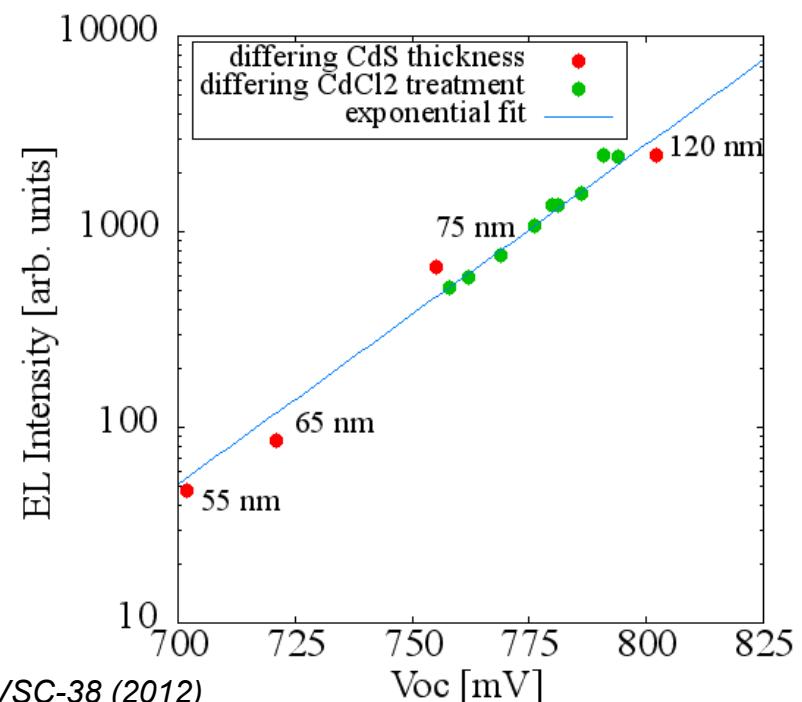


# EL Variations with Open-Circuit Voltage

Nine CdTe cells on same substrate  
with varying voltage and EL response  
(non-uniform CdCl<sub>2</sub> responsible)



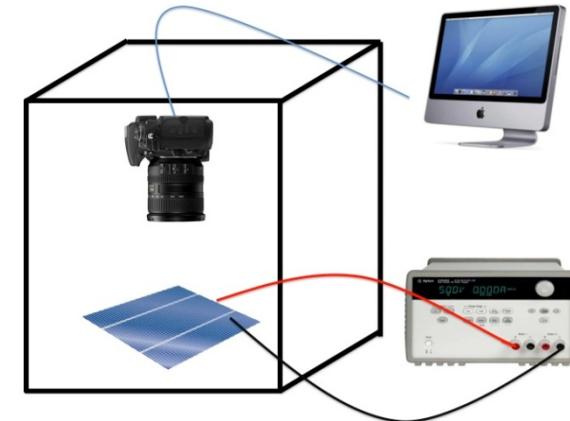
Raguse et al, PVSC-38 (2012)



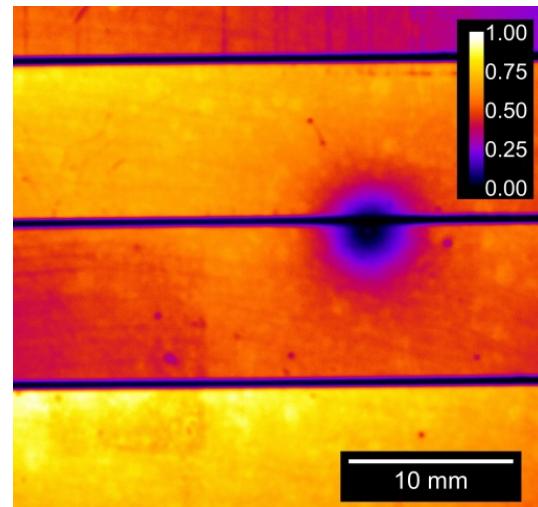
Well-behaved relation between voltage and EL response

# EL: Two Types of Shunt

Module from before

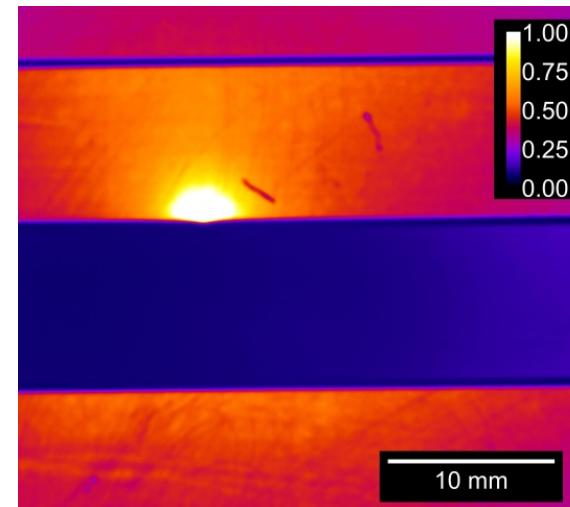


Shunt in the lower cell



Diameter of affected area ~ 3 mm

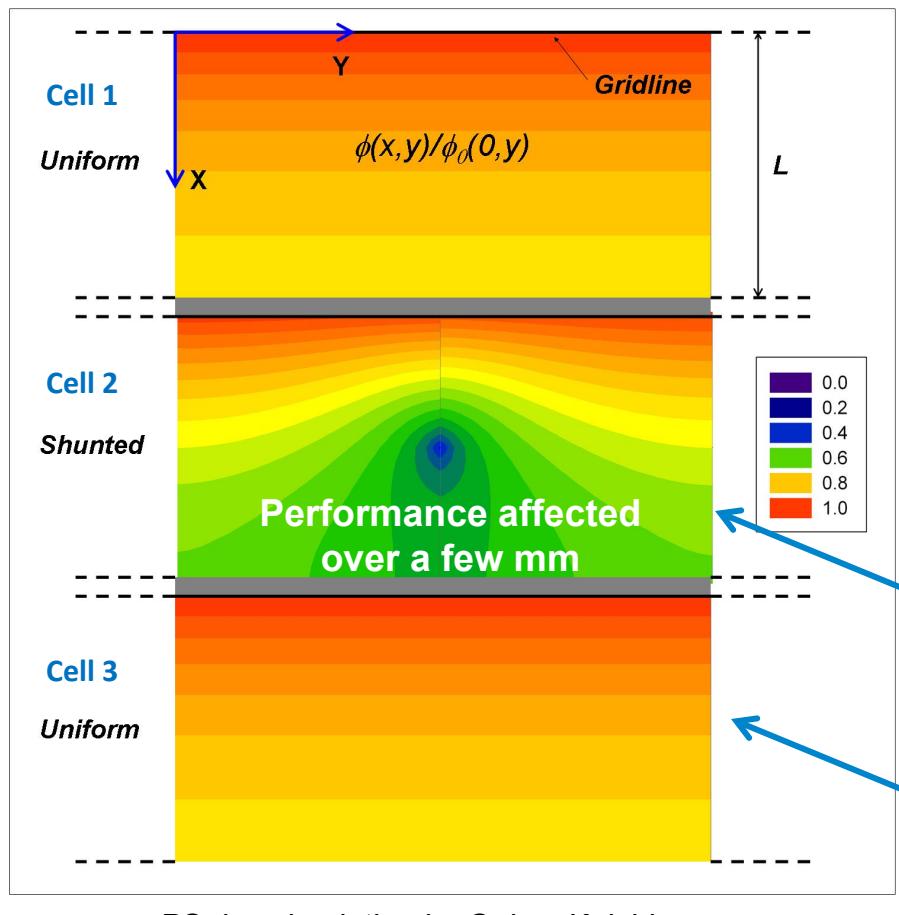
Shunt between two cells



Raguse et al,  
PVSC-38 (2012)

Lower-cell current transferred to upper cell

# Shunt Effect Using Circuit Modeling



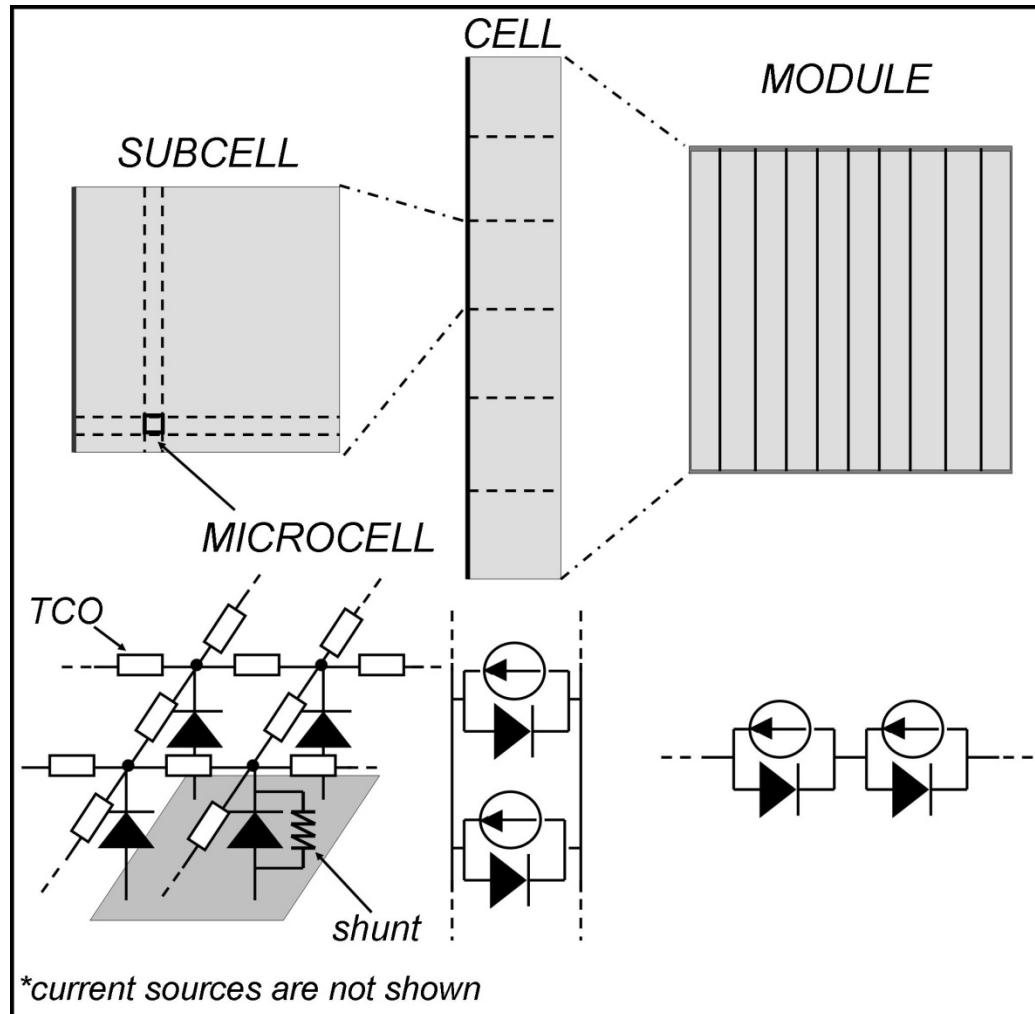
Shunts can be distinguished from dust or weak diode areas

Impacted area (about 3 mm here also) depends on TCO sheet resistance

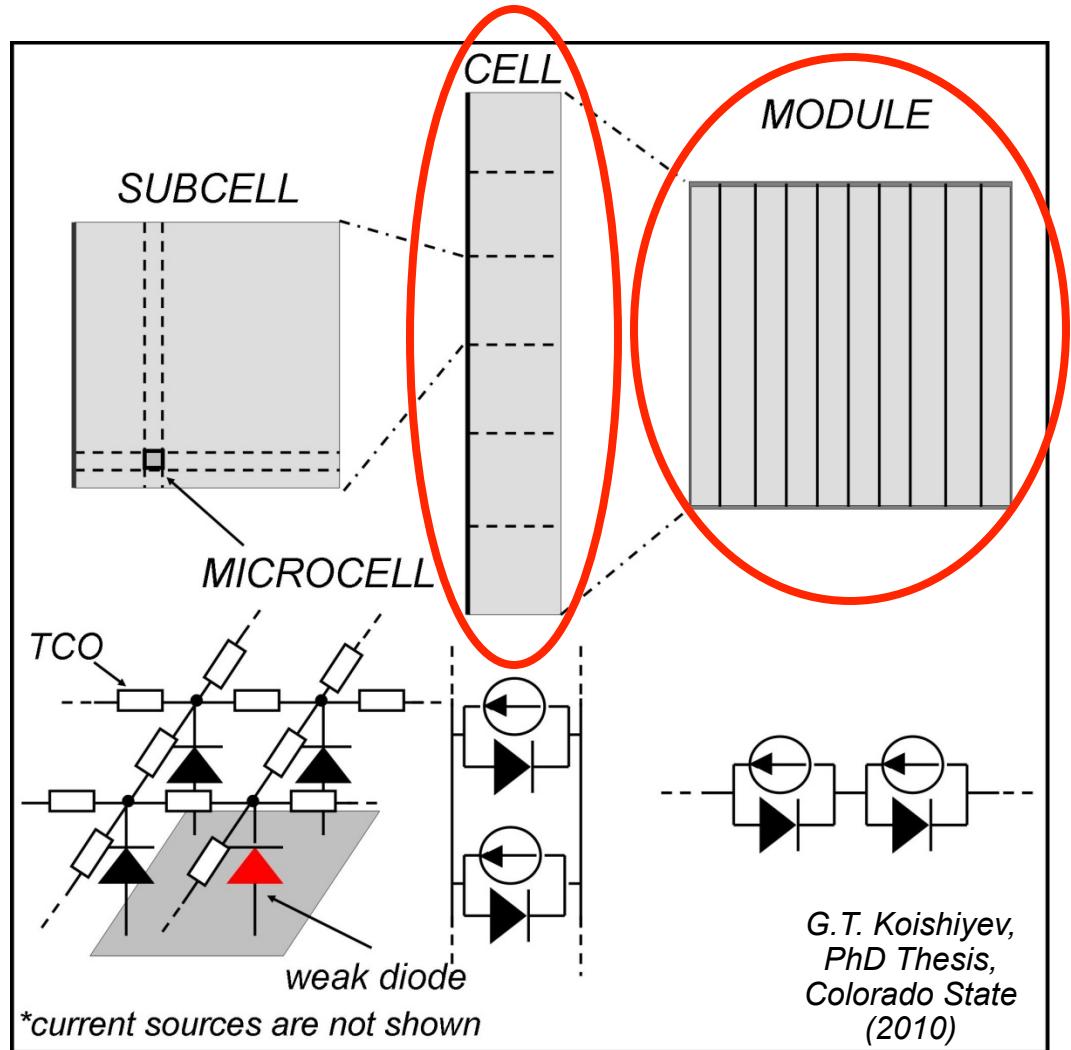
Reduced voltage from shunt superimposed on background

No shunt: voltage drop across cell.

# Extension to Multiple Shunts

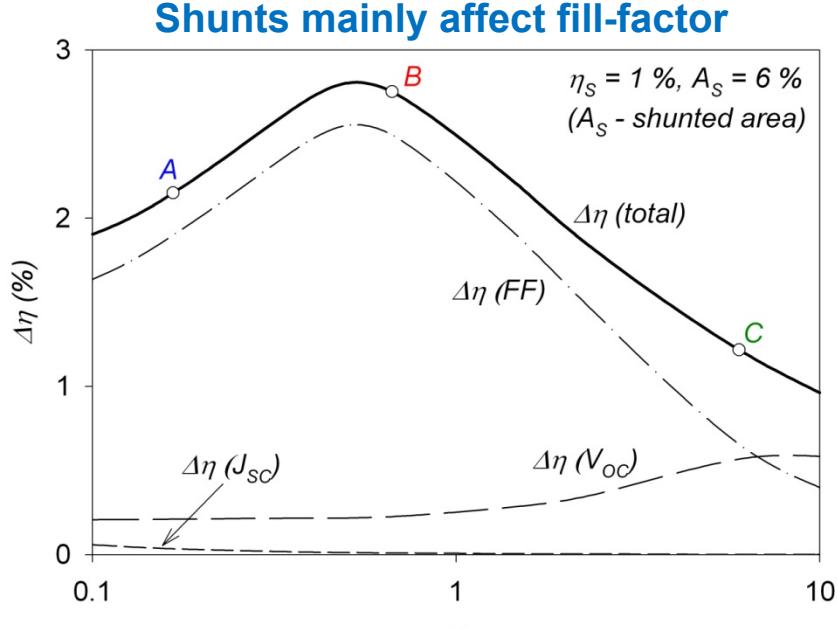
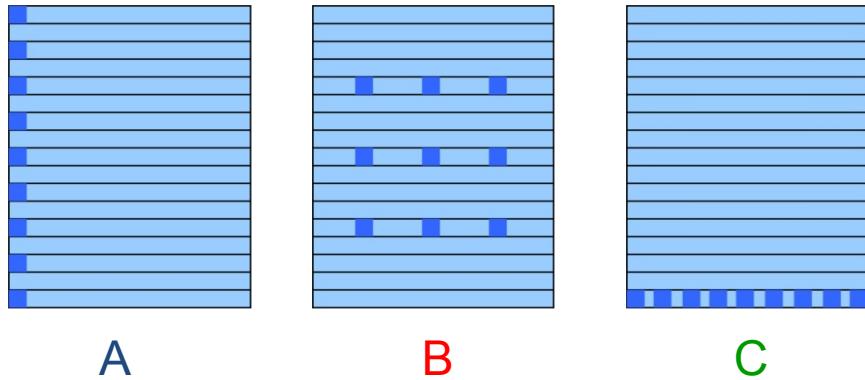


# Extension to Multiple Shunts



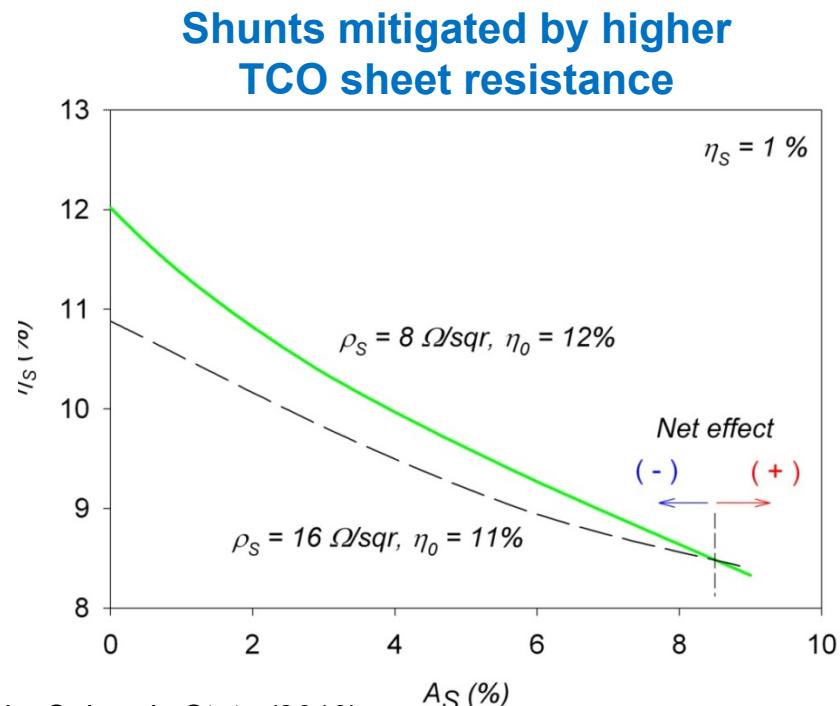
- (1) Now combine subcells, some fraction of which are non-uniform, but most of which are uniform, into cells (1-D, parallel)
- (2) Then combine cells into a module (1-D, series)

# Distribution of Shunts in a Module



G.T. Koishiyev. PhD Thesis, Colorado State (2010)

- A – Shunts spread over many cells**
- B – Intermediate**
- C – Shunts in one or two cells**  
preferred for shunts (or weak diodes)



# Summary

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- (1) Several different types of PV modeling; each has value for specific types of problems.
- (2) Uniformity modeling is particularly important for CIGS and CdTe, BUT analysis is relatively immature.
- (3) Always helpful to have direct comparisons with experimental data, and if at all possible give credible physical interpretation of modeling results.
- (4) Modeling failures can sometimes be as illuminating as successes.